



00862.023157

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROSHI WATANABE ET AL.

Application No.: 10/619,576

Filed: July 16, 2003

For: SUBSTRATE PROCESSING
METHOD AND SUBSTRATE
PROCESSING APPARATUS

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: Examiner: B. Carrillo
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: Group Art Unit: 1746
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March 21, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

A. Introductory Comments

Prior to the examination on the merits, please amend the above-captioned application as follows and consider the following remarks.